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Atty. Docket No.: 0932/00381

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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In re the Patent Application of

Ivan Berry et al.

Serial No. 09/505,695

Group Art Unit: Not Yet Assigned

Filed: February 17, 2000

Examiner: Not Yet Assigned

Title: Method of Photoresist Ash Residue Removal

SECOND STATUS REQUEST

Commissioner of Patents
Washington, D.C. 20231

Sir:

Please advise the undersigned attorney of the status of the subject patent application.

The application was filed on February 17, 2000 without a Declaration, but no notice of missing parts was ever received.

A timely response would be appreciated, as this is the second request for status made.

Respectfully submitted,

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